

Notice of References Cited	Application/Control No. 10/785,598	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,598,281	01-1997	Zimmerman et al.	349/5
*	B	US-4,240,692	12-1980	Winston, Roland	385/146
*	C	US-7,001,060	02-2006	Kimura, Hajime	362/620
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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